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Class	Subclass
ISSUE CLASSIFICATION	

**U.S. UTILITY Patent Application**

 O.I.P.E. SCANNED <u>A.C. 2</u> Q.A. <u>WIT</u>	PATENT DATE _____
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APPLICATION NO. 09/851089	CONT/PRIOR. F	CLASS 015 134	SUBCLASS 77	ART UNIT 1744	EXAMINER <del>CHIN</del> COLE
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**TITLE:**

# Cleaning apparatus for semiconductor wafer

PTO-2040  
12/99[illegible]

<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>	<b>DRAWINGS</b>			<b>CLAIMS ALLOWED</b>	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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